

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: : **Mami MIYASAKA**
Filed : **Concurrently herewith**
For : **ELECTRON BEAM EXPOSURE MASK,...**
Serial No. : **Concurrently herewith**

September 8, 2003

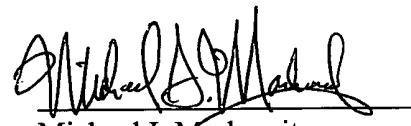
Commissioner for Patents
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PRIORITY CLAIM AND
SUBMISSION OF PRIORITY DOCUMENT

S I R:

Applicant hereby claims priority under 35 USC 119 from **Japanese** patent application number **11-232358** filed **August 19, 1999**, a copy of which was made of record in parent application number **09/641,125**.

Respectfully submitted,


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